



## INFORMATION DISCLOSURE STATEMENT

Case Name: T. Kroupenkine 22-23-6-13-19  
Serial No. 10/803576  
Applicant: Kroupenkine et al.  
Filing Date: March 18, 2004  
Group:

## U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date
J	AA	6,185,961	2/13/2001	Tonucci, et al.	65	60.4	1/27/1999
	<del>AB</del>	<del>US Pat. App. 10/798864</del>		<del>Arney, et al</del>			<del>3/11/2004</del>
	<del>AC</del>	<del>US Pat. App. 10/806543</del>		<del>Arney, et al</del>			<del>3/23/2004</del>
	<del>AD</del>	<del>US Pat. App. 10/816589</del>		<del>Gasparyan, et al.</del>			<del>4/1/2004</del>
	<del>AE</del>	<del>US Pat. App. 10/674448</del>		<del>Hodes, et al.</del>			<del>9/30/2003</del>
	<del>AF</del>	<del>US Pat. App. 10/803565</del>		<del>Hodes, et al.</del>			<del>9/18/2004</del>
	<del>AG</del>	<del>US Pat. App. 10/803641</del>		<del>Hodes, et al.</del>			<del>3/18/2004</del>
	<del>AH</del>	<del>US Pat. App. 10/409159</del>		<del>Kornblit, et al.</del>			<del>3/31/2003</del>
	<del>AI</del>	<del>US Pat. App. 10/649285</del>		<del>Kornblit, et al.</del>			<del>8/27/2003</del>
	<del>AJ</del>	<del>US Pat. App. 10/716084</del>		<del>Kroupenkine, et al.</del>			<del>11/18/2003</del>
	<del>AK</del>	<del>US Pat. App. 10/803576</del>		<del>Kroupenkine, et al.</del>			<del>3/18/2004</del>
	<del>AL</del>	<del>US Pat. App. 10/816774</del>		<del>Kroupenkine, et al.</del>			<del>3/26/2004</del>

## FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation

## OTHER (including Author, Title, Date, Pertinent Pages, etc.)

J	AM	Kim, et al., "Nanostructured Surfaces for Dramatic Reduction of Flow Resistance in Droplet-Based Microfluidics," IEEE, pp. 479-482 (2002). (no entry)

\*\*\*References listed beyond AZ would list as AA-1, AB-2, AC-3 thru AZ-26.

\*\*\*Note First Page ONLY Header/Footer. Subsequent pages must ONLY have page # layout as header

EXAMINER

DATE CONSIDERED

6/25/07

\*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant